

<b>Notice of References Cited</b>		Application/Control No. 10/565,152	Applicant(s)/Patent Under Reexamination MCNIE ET AL.	
		Examiner Chad H. Smith	Art Unit 2874	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,381,426	01-1995	Fontana et al.	372/18
*	C	US-5,525,190	06-1996	Wojnarowski et al.	385/133
*	D	US-6,090,636	07-2000	Geusic et al.	438/31
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	R.M. Jenkins et al., "A Hollow Waveguide Integrated Optic Subsystem for a 10.6 um Range-Doppler Imaging Lidar", 2000, Proceedings of SPIE, Vol. 4034, pgs. 108 - 113
*	V	Krippner et al., "Microspectrometer System for the Near Infrared Wavelength Range based on the LIGA Technology", 2000, Proceedings of SPIE, Vol. 3912, pgs. 141 - 149
*	W	R. Foord, et al., "A Hollow Waveguide Integrated Optic System with an Integrated Laser Source", 2000, Proceedings of SPIE, Vol. 4035, pgs. 346 - 353
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.